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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jeffrey Drue David                      Art Unit : 3723  
Serial No. : 10/643,583                              Examiner : Maurina T. Rachuba  
Filed : August 18, 2003  
Title : PLATEN AND HEAD ROTATION RATES FOR MONITORING CHEMICAL  
MECHANICAL POLISHING

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Applicant respectfully notes that not all of the limitations noted by the Examiner may be required for patentability, and that other reasons for patentability may exist.

Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 10/12/05

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I hereby certify that this correspondence is being transmitted by facsimile to the Patent and Trademark Office on the date indicated below.

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